## Masaki Numazawa

## List of Publications by Year in descending order

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1937685 2053705 5 31 4 5 citations h-index g-index papers 5 5 5 37 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Pt thermal atomic layer deposition for silicon x-ray micropore optics. Applied Optics, 2018, 57, 3237.	1.8	10
2	First X-ray imaging with a micromachined Wolter type-I telescope. Microsystem Technologies, 2017, 23, 1101-1116.	2.0	9
3	Grinding and chemical mechanical polishing process for micropore x-ray optics fabricated with deep reactive ion etching. Applied Optics, 2019, 58, 5240.	1.8	6
4	Enhanced X-ray reflectivity from Pt-coated silicon micropore optics prepared by plasma atomic layer deposition. Applied Physics Express, 2020, 13, 087001.	2.4	5
5	Improvement of imaging performance of silicon micropore X-ray optics by ultra long-term annealing. Optics Express, 2022, 30, 25195.	3.4	1